

11/13/01
1046 U.S. PTO
10/003042
11/13/01

DLS:lam 11/13/01 81807.doc
Attorney Reference Number 4641-61595
PATENT

EXPRESS MAIL LABEL NO. EL874429916US
DATE OF DEPOSIT: November 13, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BOX PATENT APPLICATION
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231



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Transmitted herewith for filing is the patent application of:

Inventor(s): Shigeru Nakayama, Yuichi Takigawa and Takashi Gemma

For: METHODS FOR MEASURING A SURFACE PROFILE OF AN OPTICAL ELEMENT

Enclosed are:

- ☒ 10 pages of specification, 3 pages of claims (all in the Japanese language, 37 C.F.R. § 1.52(d)), and a Combined Declaration and Power of Attorney (unsigned).
- ☒ 5 sheet(s) of drawings.
- ☒ Applicants claim the benefit under 35 U.S.C. § 119 of the respective earlier filing dates of Japan Patent Application No. 2000-346505, filed on November 14, 2000, and Japan Patent Application No. 2001-336084, filed November 1, 2001.
- ☒ The Director is hereby authorized to charge any additional fees that may be required in connection with the filing of this application and recording any assignment filed herewith, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

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cc: Docketing